

2826



Cofu
7/26/02

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

DEV ALOK

Serial No. 09/894,084

Filed: JUNE 28, 2001

Title: SILICON CARBIDE SHOTTKY BARRIER DIODE AND METHOD OF MAKING

Commissioner for Patents
Washington, D.C. 20231

Atty. Docket

US 010292

Group Art Unit: 2826

Examiner: M. L. TRAN

#5/A
Andt
J. Amiller
8/7/02

AMENDMENT

Sir:

In response to the official Office Action dated June 27, 2002, please amend the above-identified application as follows:

IN THE CLAIMS

Kindly cancel Claims ~~9-17~~ without prejudice.

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REMARKS

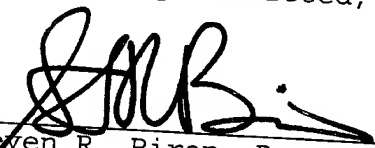
In the outstanding Official Action, restriction was required as between Claims 9-17, drawn to a Schottky barrier diode and Claims 1-8, drawn to a method of making a Schottky barrier diode.

In response, Applicant hereby elects Claims 1-8 for an examination on the merits, without prejudice to Applicant's

right to subsequently file a divisional application directed to the nonelected claims.

A favorable action on the merits is earnestly solicited.

Respectfully submitted,

By 
Steven R. Biren, Reg. 26,531
Attorney
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CERTIFICATE OF MAILING

It is hereby certified that this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to:

COMMISSIONER OF PATENTS AND TRADEMARKS
Washington, D.C. 20231

On July 26, 2002
By Elissa De Lacey